

Docket No.: 60188-670

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Taiji NODA	:	Confirmation Number:
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: October 02, 2003	:	Examiner: Unknown
	:	
For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME	:	

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

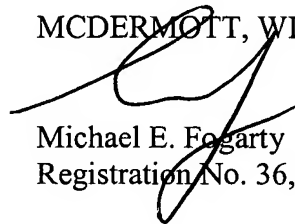
The relevance of Japanese Unexamined Patent Publication No. 08-250729 is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:tlb
Facsimile: (202) 756-8087
Date: October 2, 2003

INFORMATION DISCLOSURE CITATION IN AN APPLICATION				ATTY. DOCKET NO. 60188-670		SERIAL NO.		
(PTO-1449)				APPLICANT Taiji NODA				
				FILING DATE October 02, 2003		GROUP		
U.S. PATENT DOCUMENTS								
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (if known)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	B1	US	6,432,802	08/13/2002	Noda et al.			
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
		US						
FOREIGN PATENT DOCUMENTS								
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4 -Kind Codes (if known)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
							Yes	No
		JP 8-250729		09/27/1996	ADVANCED MICRO DEVICES INC		(Japan w/English Abstract)	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.						
		Noda et al., "Effects of end-of-range dislocation loops on transient enhanced diffusion of indium implanted in silicon", JOURNAL OF APPLIED PHYSICS, PP.4980-4984, November 1, 2000.						
		T. Noda, "Modeling of End-of-Range (EOR) Defects for Indium Channel Engineering", Tech. Dig. IEDM, p.839, 2001						
EXAMINER				DATE CONSIDERED				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.